

<b>Search Notes</b>	<b>Application/Control No.</b>	<b>Applicant(s)/Patent Under Reexamination</b>
	10544120	OHBAYASHI ET AL.
	<b>Examiner</b>	<b>Art Unit</b>
	JASMINE PRITCHARD	2614

### SEARCHED

<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>
381	174, 175	1/30/2009	J. Pritchard
381	174, 175	8/11/2009	J. Pritchard

### SEARCH NOTES

<b>Search Notes</b>	<b>Date</b>	<b>Examiner</b>
Inventor name searches: Ohbayashi, Yauda, Saeki, Komai, Kagawa	1/28/2009	J. Pritchard
Oxide and Nitride, silicon film, layers	1/28/2009	J. Pritchard
Personal consultation with Suhan Ni	1/29/2009	J. Pritchard
Personal consultation with Suhan Ni	8/10/2009	J. Pritchard

### INTERFERENCE SEARCH

<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>

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Examiner.Alt Unit 2614